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GROUP 1700

503.36911X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. ONO, et al

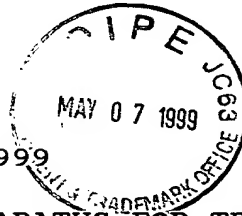
Serial No.: 09/249,292

Filed: February 12, 1999

For: METHOD AND APPARATUS FOR TREATING SURFACE OF
SEMICONDUCTOR

Group: 1763

Examiner:



H2A
5/17/99

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

May 7, 1999

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

IN THE SPECIFICATION:

Please replace the original specification with the attached Substitute Specification.

IN THE CLAIMS:

Please amend the claims as follows:

Claim 6, line 2, delete "the" insert --a--;

line 4, delete "the" insert --a--.